



42390.P11026

#21/c
10/9/03
Malick
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kloster, et al.

Serial No.: 09/820,079

Filed: March 28, 2001

For: STRUCTURE IN A
MICROELECTRONIC DEVICE
INCLUDING A BI-LAYER FOR A
DIFFUSION BARRIER AND AN
ETCH STOP LAYER

Examiner: Thomas J. Magee

Group Art Unit: 2811

Attorney Docket No.: 42390.P11026

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9/30/03
Date

AMENDMENT

Hon. Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the August 28, 2003 Office Action, Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks: